

Docket No.: 0505-1267P  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Toshio YAMAGIWA et al.

Application No.: 10/774,446

Confirmation No.: 1682

Filed: February 10, 2004

Art Unit: 3617

For: MOUNTING STRUCTURE OF THE  
PRESSURE SENSING SYSTEM

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Examiner: F. F. Jules

**AMENDMENT UNDER 37 C.F.R. 1.116**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated November 9, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes: Amendments to the Claims and Remarks.